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**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2825**

PATENT

Attorney Docket No. 03180.0360

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Satoshi Tanaka et al.)	Group Art Unit: 2825
)	
Application No.: 10/808,299)	Examiner: MEMULA, Suresh
)	
Filed: March 25, 2004)	
)	Confirmation No.: 7279
For: SET OF MASKS, METHOD OF)	
GENERATING MASK DATA AND)	Mail Stop AF
METHOD FOR FORMING A)	
PATTERN)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION

In reply to the Final Office Action mailed May 18, 2007, the period for response to which extends through August 20, 2007 (August 18th being a Saturday), Applicants request the Examiner's reconsideration in view of the remarks that follow:

Remarks begin at page 2 of this paper.